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PATENT
ATTORNEY DOCKET NO.: 049128-5144

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	
Byung Chul AHN, et al.)	Confirmation No.: 8591
)	
Application No.: 10/774,701)	Group Art Unit: 2879
)	
Filed: February 10, 2004)	Examiner: Unassigned
)	
For: METHOD OF PATTERNING)	
TRANSPARENT CONDUCTIVE FILM,)	
THIN FILM TRANSISTOR SUBSTRATE)	
USING THE SAME AND FABRICATING)	
METHOD THEREOF)	

Commissioner for Patents
Customer Window
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir:

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97(b)

Pursuant to 37 C.F.R. §§ 1.56 and 1.97(b), Applicants bring to the attention of the Examiner the documents listed on the attached PTO Form 1449. To the best of the undersigned's knowledge, this Information Disclosure Statement is being filed before the mailing date of a first Office Action on the merits for the above-referenced application. Accordingly, Applicants do not believe that a fee is due for filing this paper.

The document listed in this Information Disclosure Statement (IDS) was cited in an Office Action issued by the Korean Patent Office on February 14, 2005 in a counterpart foreign application. A copy of the Office Action is enclosed. The relevance of JP 09-29385 can be understood from the figures therein and the English language abstract.



Applicants request that the Examiner consider the listed document and evidence that consideration by making appropriate notations on the attached PTO Form 1449.

This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that the listed document is material or constitute "Prior Art." If it should be determined that the listed document does not constitute "Prior Art" under United States law, Applicants reserve the right to present to the Office the relevant facts and law regarding the appropriate status of such document.

Applicants further reserve the right to take appropriate action to establish the patentability of the disclosed invention over the listed document, should the document be applied against the claims of the present application.

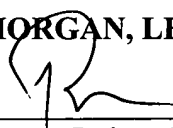
If there is any fee due in connection with the filing of this Statement, please charge the fee to our Deposit Account No. 50-0310.

Respectfully submitted,

MORGAN, LEWIS & BOCKIUS LLP

Dated: June 3, 2005

By: _____


Robert J. Goodell
Reg. No. 41,040

CUSTOMER NO. 09629
MORGAN, LEWIS & BOCKIUS LLP
1111 Pennsylvania Avenue, N.W.
Washington, D.C. 20004
Telephone: (202) 739-3000

INFORMATION DISCLOSURE CITATION (Use several sheets if necessary) PTO Form 1449				Attorney Docket No. 049128-5144		Application No.: 10/744,701	
				PAGE 1 of 1			
				Applicants: Byung Chul AHN, et al. Filing Date: February 10, 2004		Confirmation No.: 8591 Group Art Unit: 2879	

U.S. PATENT DOCUMENTS							
*Examiner Initial		Document Number	Date	Name	Class	Sub Class	Filing Date

FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Sub Class	<u>Translation</u> YES NO	
		09-293875 (w/English Abstract)	Nov. 11, 1997	Japan				
		10-2001-04024 (abstract only)	January 15, 2001	Korea				

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)		

Examiner	Date Considered
Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	